



PATENT APPLICATION

IN THE U.S. PATENT AND TRADEMARK OFFICE

April 15, 2005

Applicant : Hiroshi KAWAURA
Title : METHOD FOR FORMING CVD FILM
Serial No. : 10/692 655 Group: 1762
Confirmation No.: 9922
Filed : October 24, 2003 Examiner: Meeks
Atty. Docket No.: Ishii Case 20
Mail Stop Amendment
Commissioner for Patents
P.O. Box 1450
Alexandria, VA 22313-1450

Sir:

Herewith is an amendment in the above-identified application.

[X] Applicant claims small entity status. See 37 CFR 1.27.

[X] The additional filing fee has been calculated as shown below:

For	No. Filed	No. Extra	() LG Entity	RATE	(X) SM Entity	Fee
Total Claims	(7 - 20 = 0)		x	\$ 50.00	x \$ 25.00	
Indep. Claims	(4 - 3 = 1)		x	\$200.00	x \$100.00	100.00
[] Multiple Dep. Claim			+	\$360.00	+	\$180.00
* * * TOTAL FILING FEE * * *						\$ 100.00

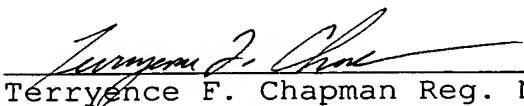
[X] Pursuant to 37 CFR 1.136(a), please extend the shortened period for response by one month. The extension fee is: \$60.00.

[X] A Check for \$160.00 is enclosed to cover fees.

[X] Please credit any overpayment, or charge any additional filing fee required under 37 CFR 1.16 or 1.17 by this communication, to Deposit Account No. 06-1382. A duplicate copy of this sheet is enclosed.

IN DUPLICATE

TFC/smd


Terryence F. Chapman Reg. No. 32 549

CERTIFICATE OF MAILING

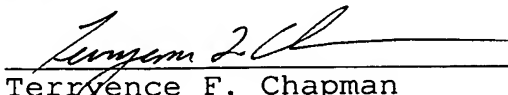
I hereby certify that this correspondence is being deposited with the United States Postal Service as first class mail in an envelope addressed to: Commissioner for Patents, P.O. Box 1450, Alexandria, VA 22313-1450, on April 15, 2005.

04/18/2005 AKELECH1 00000014 10692655

02 FC:2251

60.00 DP

130.12/04


Terryence F. Chapman